

Application/Control No.	Applicant(s)/Patent under Reexamination	
10/683,765	STRAYER, MARK	
Examiner	Art Unit	
Hae M. Hyeon	2839	

SEARCHED					
Class	Subclass	Date	Examiner		
-					
<u>-</u>					

INTERFERENCE SEARCHED					
Class	Subclass	Date	Examiner		
439	652	2/05	hmh		
439	131				

SEARCH NOTES (INCLUDING SEARCH STRATEGY)				
	DATE	EXMR		
Update Search Done	2/05	hmh		
<u>.</u>				